



## ISC Audits & Reviews SC Summary July 2016

Doc. #	Title	Result
<b>R5274G</b>	<b>Ratification Ballot, Revision to Add a New Subordinate Standard: Specification For Sensor/Actuator Network Specific Device Model Of A Generic Equipment Networked Sensor (GENSen) To SEMI E54-0413, Sensor/Actuator Network Standard</b>	<b>Passed</b>
<b>5601A</b>	<b>New Standard: Specification for Wafer Job Management</b>	<b>On Hold</b>
<b>5882</b>	<b>Line Item Revision to SEMI M10-1296 With Title Change To: Terminology for Identification of Structures and Features Seen on Gallium Arsenide Wafers</b>	
LI1;	Correct Title for Conformance	<b>Passed</b>
<b>5883</b>	<b>Line Item Revision to SEMI M42-0211 Specification for Compound Semiconductor Epitaxial Wafer</b>	
LI1;	Move section 3.3 DIN standard reference from Referenced Standards and Documents section to new section 10 Related Documents	<b>Passed</b>
<b>5884</b>	<b>Line Item Revision to SEMI M65-0306 With Title Change To: Specification for Sapphire Substrates to use for Compound Semiconductor Epitaxial Wafers</b>	
LI1;	Correct the title of this standard from "Specifications" to "Specification"	<b>Passed</b>
<b>5885</b>	<b>Line Item Revision to SEMI M75-0812 With Title Change To: Specification for Polished Monocrystalline Gallium Antimonide Wafers</b>	
LI1;	Correct the title of this standard from "Specifications" to "Specification"	<b>Passed</b>
<b>5886</b>	<b>Line Item Revision to SEMI M9-0914 With Title Change To: Specification for Polished Monocrystalline Gallium Arsenide Wafers</b>	
LI1;	Correct title and concomitant text of SEMI M9	<b>Passed</b>

Line Item (LI)

All other documents passed and will be forwarded to Standards Publications for final processing. Contact your regional staff if there is any question.

KN  
VI  
July 20, 2016